

<b>Notice of References Cited</b>	Application/Control No. 10/582,578		Applicant(s)/Patent Under Reexamination WIMBERGER-FRIEDL ET AL.	
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#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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#### FOREIGN PATENT DOCUMENTS

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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Hanemann et al., Micro- and Nanopatterning Polymers, "Molding of Polymeric Microstructures", 01 September 1998, pp. 67-75, <a href="http://dx.doi.org/10.1021/bk-1998-0706.ch006">http://dx.doi.org/10.1021/bk-1998-0706.ch006</a>
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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